



03-10-05

IFW

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Walter SCHWARZENBACH et al.

Confirmation No. 9739

Application No.: 10/733,729

Group Art Unit: 2812

Filing Date: December 12, 2003

Examiner: D. NHU

For: METHOD OF MAKING CAVITIES IN A
SEMICONDUCTOR WAFER

Atty. Docket No.: 4717-9200

RESPONSE TO RESTRICTION

Commissioner of Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Examiner's restriction requirement dated March 3, 2005,
applicants elect method claims 1-19 of Group I for examination in this application.

No fees are believed to be due for this amendment. Should any fees be required,
please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

3-9-05
Date

Allan A. Fanucci
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